

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10519724
<b>Filing Date:</b>	28-Dec-2004
<b>Title of Invention:</b>	Device and method for the production of chlorotriflouride and system for etching semiconductor substrates using said device
<b>First Named Inventor/Applicant Name:</b>	Franz Laermer
<b>Filer:</b>	Gerard A. Messina/Tesha Ramos
<b>Attorney Docket Number:</b>	10191/3980

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				
Extension - 2 months with \$0 paid	1252	1	460	460

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>460</b>